

References

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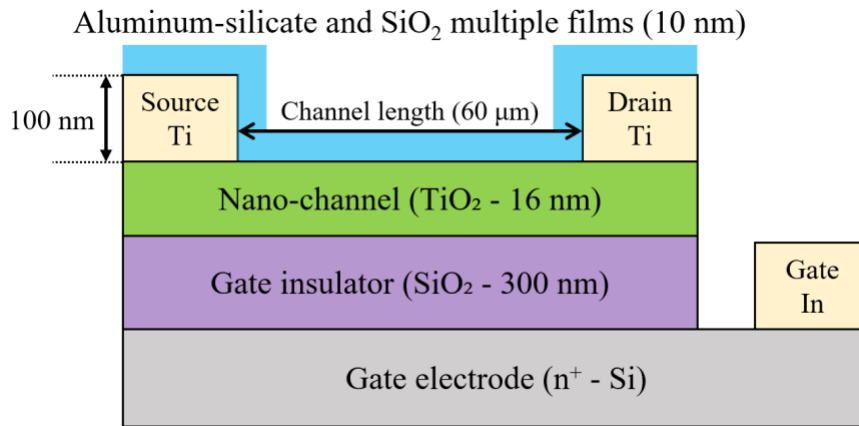


Fig.1 Schematic of TiO₂-TFT with aluminum-silicate and SiO₂ multiple films.

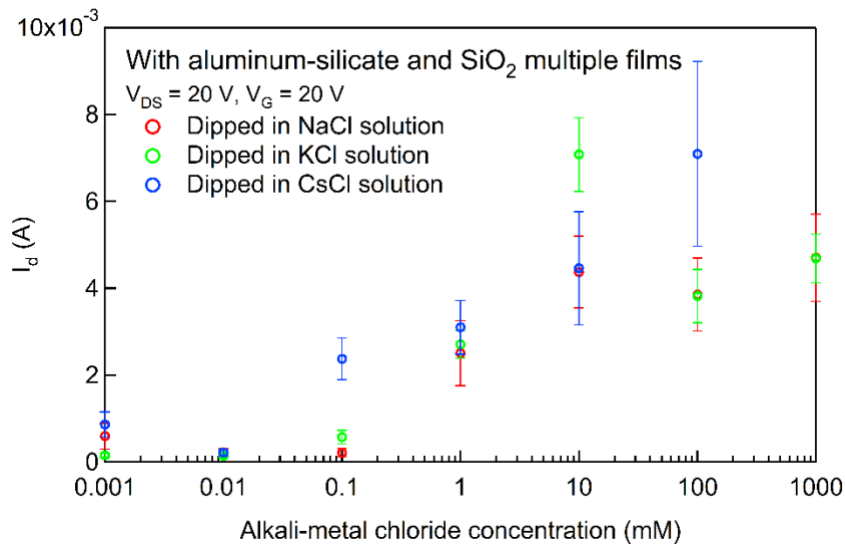


Fig.2 Correlation between alkali-metal chloride concentration and drain current. TiO₂-TFT with aluminum-silicate and SiO₂ multiple films.